

## Electronic Patent Application Fee Transmittal

Application Number:	10734479
Filing Date:	12-Dec-2003
Title of Invention:	Method for cleaning a deposition chamber and deposition apparatus for performing in situ cleaning
First Named Inventor:	Eun-Taek Yim
Filer:	Alexander Charles Johnson/Li mei Vermilya
Attorney Docket Number:	2522-042

Filed as Large Entity

### Utility Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Basic Filing:

Pages:

Claims:

Independent claims in excess of 3	1201	1	200	200
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Miscellaneous-Filing:

Petition:

Patent-Appeals-and-Interference:

Post-Allowance-and-Post-Issuance:

Extension-of-Time:

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
<b>Total in USD (\$)</b>				<b>200</b>